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PATENT  
Attorney Docket No.: 18062L-006400  
UC Case No. B03-016-1



On 3-22-05

TOWNSEND and TOWNSEND and CREW LLP

By: Linda Sheffer

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Di Gao et al.

Application No.: 10/613,508

Filed: July 3, 2003

For: SELECTIVE ETCHING OF  
SILICON CARBIDE FILMS

Examiner: David E. Graybill

Art Unit: 2822

SUPPLEMENTAL INFORMATION  
DISCLOSURE STATEMENT UNDER 37  
CFR §1.97 and §1.98

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The references cited on attached forms PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references [excluding cited U.S. Patents, U.S. Patent Application publications, and appropriate IFW-stored, pending U.S. Patent Applications and portions thereof, per 1287 OG 163] are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

Also enclosed is a copy of the Search/Examination report corresponding to the PCT application.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicants believe that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



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Substitute for form 1449A&B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)			<b>Complete if Known</b>		
			Application Number	10/613,508	
			Filing Date	July 3, 2003	
			First Named Inventor	Gao, Di	
			Art Unit	2822	
			Examiner Name	David E. Graybill	
Sheet	2	of	2	Attorney Docket Number	18062L-006400

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>	
	2	DI GAO et al., <i>The 12th International Conference on Solid State Sensors, Actuators and Microsystems</i> , 2:1160-1163 (2003)		
	3	LANOIS et al., <i>Applied Physics Letters</i> , 69(2):236-238 (1996)		
	4	ZHAO et al., <i>Proceedings of the International Symposium on Plasma Processing</i> , 96(12):410-415 (1996)		

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.